



Docket No.: 060188-0578

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Customer Number: 20277
Shinichi IMAI, et al.	:	Confirmation Number: 4939
Application No.: 10/619,191	:	Group Art Unit: 2125
Filed: July 15, 2003	:	Examiner: Maria N. Von Buhr
For: SYSTEM AND METHOD FOR MONITORING SEMICONDUCTOR PRODUCTION APPARATUS		

AMENDMENT UNDER 37 CFR § 1.111

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following amendments and remarks are submitted under 37 CFR § 1.111 in response to the non-final Office Action mailed June 21, 2006.

Amendments to the Claims begin on page 2.

Remarks begin on page 6.